

Notice of References Cited	Application/Control No. 09/800,904	Applicant(s)/Patent Under Reexamination KIM ET AL.	
	Examiner George Fourson	Art Unit 2823	Page 1 of 1

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*		Document Number Country Code-Number-Kind Code	Date MM-YYYY	Name	Classification
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	B	US-			
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	D	US-			
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	I	US-			
	J	US-			
	K	US-			
	L	US-			
	M	US-			

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NON-PATENT DOCUMENTS

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	U	Suzuki, Hisao, et al., "Low-Temperature Processing of Highly Oriented Pb(ZrxTi1-x)O3 Thin Film with Multi-Seeding Layers", Jpn.J.Appl.Phys., Vol.36(1997)pp.5803-5807, Part 1, No. 9B, 9-1987
	V	Yoon, Ki Hyun, et al., "Stacking Effects on Dielectric Properties of Sol-Gel Derived Pb(Zr0.53Ti0.47)O3/PbTiO3 Thin Films", J.Appl.Phys., Vol.83, No.7, 4-1998, pp.3626-3629
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	X	

*A copy of this reference is not being furnished with this Office action. (See MPEP § 707.05(a).)
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